WHAT IS CLAIMED IS:

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1. A method for manufacturing carbon fiber,
comprising:

a step of forming a coated film containing a metal organic compound and a water-soluble polymer compound by applying an ink for producing a catalyst comprising a solution containing at least the metal organic compound and the polymer compound onto a substrate,

a step of forming catalyst particles comprising a metal constituting said metal organic compound by heating said coated film, and

a step of forming carbon fibers by bringing a gas containing carbon into contact with the catalyst particles.

- 2. The method according to claim 1, wherein said polymer compound is any one selected from the group consisting of polyvinyl alcohol, polyacrylic acids and polyvinylpyrrolidone.
- 3. The method according to claim 1, wherein said metal constituting the metal organic compound is any one selected from the group consisting of Pd, Fe, Co and Ni.
 - 4. The method according to claim 1, wherein

said metal organic compound is a metal organic complex.

- 5. The method according to claim 1, wherein a main solvent of said catalyst-manufacturing ink is water.
- 6. The method according to claim 1, wherein a main solvent of said catalyst-manufacturing ink is an organic solvent.
 - 7. The method according to claim 1, wherein the step of heating said coated film is carried out in a non-oxidizing atmosphere.

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8. The method according to claim 1, wherein the step of heating said coated film is a step of baking the coated film in an oxidizing atmosphere and then heating it in a reducing atmosphere.

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- 9. The method according to claim 1, wherein said gas containing carbon is a hydrocarbon gas.
- 10. The method according to claim 1, wherein said gas containing carbon is a mixed gas of a hydrocarbon gas with hydrogen gas.

11. A method for manufacturing an electron emitting device containing carbon fibers connected to an electrode comprising at least:

a step of forming a coated film containing a metal organic compound and a water-soluble polymer compound by applying an ink for producing a catalyst comprising a solution containing at least the metal organic compound and the water-soluble polymer compound onto the electrode,

a step of forming catalyst particles
comprising a metal constituting said metal organic
compound on said electrode by heating said coated
film, and

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a step of forming carbon fibers by bringing a gas containing carbon into contact with the catalyst particles.

- 12. The method according to claim 11, wherein said polymer compound is any one selected from the group consisting of polyvinyl alcohol, polyacrylic acids and polyvinylpyrrolidone.
- 13. The method according to claim 11, wherein said metal constituting the metal organic25 compound is any one selected from the group consisting of Pd, Fe, Co and Ni.

- 14. The method according to claim 11, wherein said metal organic compound is a metal organic complex.
- 5 15. The method according to claim 11, wherein said gas containing carbon is a mixed gas of a hydrocarbon gas with hydrogen gas.
- 16. An ink for producing a catalyst for
 10 growing carbon fibers, comprising at least a metal
 organic compound, a water-soluble polymer compound
 and a solvent.
- 17. The catalyst-manufacturing ink according to claim 16, wherein said polymer compound is any one selected from the group consisting of polyvinyl alcohol, polyacrylic acids and polyvinylpyrrolidone.
- 18. The catalyst-manufacturing ink according
 20 to claim 16, wherein said metal constituting the
 metal organic compound is any one selected from the
 group consisting of Pd, Fe, Co, and Ni.
- 19. The catalyst-manufacturing ink according 25 to claim 16, wherein said metal organic compound is a metal organic complex.

- 20. The catalyst-manufacturing ink according to claim 16, wherein said solvent is mainly water.
- 21. The catalyst-manufacturing ink according to claim 16, wherein said solvent is mainly an organic solvent.
- 22. A method for manufacturing a display using a plurality of electron emitting devices,
 wherein said electron emitting devices are manufactured by the method according to claim 11.